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*AF/1765*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*61*  
In re application of:

Uzoh et al.

Serial No.: 10/032,219

Filed: December 21, 2001

Title: METHOD AND SYSTEM TO  
PROVIDE ELECTOPLANARIZATION OF A  
WORKPIECE WITH A CONDUCTING  
MATERIAL LAYER

Group Art Unit: 1765

Examiner: Chen, Kin Chan

Docket: NT-235-US

CERTIFICATE OF MAILING

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Signed: *[Signature]*

Amy Alwine

AMENDMENT UNDER 35 USC § 1.116

*Do not enter.*

Commissioner for Patent  
P.O. Box 1450  
Alexandria, VA 22313

*K-cc 2/13/04*

Dear Sir:

In response to the Final Office Action mailed January 15, 2004, Applicants request entry and consideration of the following Remarks and Amendment, which better present the claims for consideration on appeal. Please amend the above-identified application as follows:

The Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.